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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10083756	FILING DATE 02/25/2002	CLASS 257	SUBCLASS	GAU 2811	EXAMINER Q. Vn
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**APPLICANTS: Kim Do-Hyung; Kim Sung-Eui;

**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:

REPUBLIC OF KOREA 2001-09382 02/23/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		4591-227	
Verified and Acknowledged Examiners's initials			
TITLE : Method for forming layer for trench isolation structure			

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner			
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheet Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner PREPARED FOR ISSUE Application Examiner	
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